



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6435**
Takahisa HAYASHI : Docket No. 2003_1559A
Serial No. 10/699,734 : Group Art Unit 2826
Filed November 4, 2003 : Examiner Victor A. Mandala

SEMICONDUCTOR
DEVICE AND METHOD OF
MANUFACTURING THE SAME : **Mail Stop: Amendment**

AMENDMENT THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of February 7, 2005, please amend the above-identified U.S. Patent application as follows: